Relationship Between Ridge Count and Pattern Intensity Index
In Digital Dermatoglyphics Among the Wancho
Of Arunachal Pradesh, India’

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Abstract The relationship between pattern intensity index with total finger ridge count and absolute finger ridge counts has been investigated in Wancho, a Mongoloid population of Tirap district, Arunachal Pradesh, India. The results show a stronger linear relationship between pattern intensity index and the absolute finger ridge count than with total finger ridge count.